

2001/08/02/01
Docketing
10/10/01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Lancy Tsung	Docket No.: TI-30243
Serial No: TBD	Examiner: TBD
Filed: 08/02/01	Art Unit: TBD
For: MASS PRODUCTION OF CROSS-SECTION TEM SAMPLES BY FOCUSED ION BEAM DEPOSITION AND ANISOTROPIC ETCHING	

PRELIMINARY AMENDMENT

August 2, 2001

Assistant Commissioner for Patents

Washington, DC 20231

Dear Sir:

Please amend the above referenced application as follows:

In the Specification:

Page 1, before line 1, insert - This application claims priority under 35 USC §

A₁ 119(e)(1) of provisional application numbers 60/222,462 filed 08/03/00.--
